Reducing Nitrogen Content in Silicon Carbide Crystals by Sublimation Growth in a Hydrogen-Containing Ambient

In re: George Fechko Attorn y Docket No. 5000.302

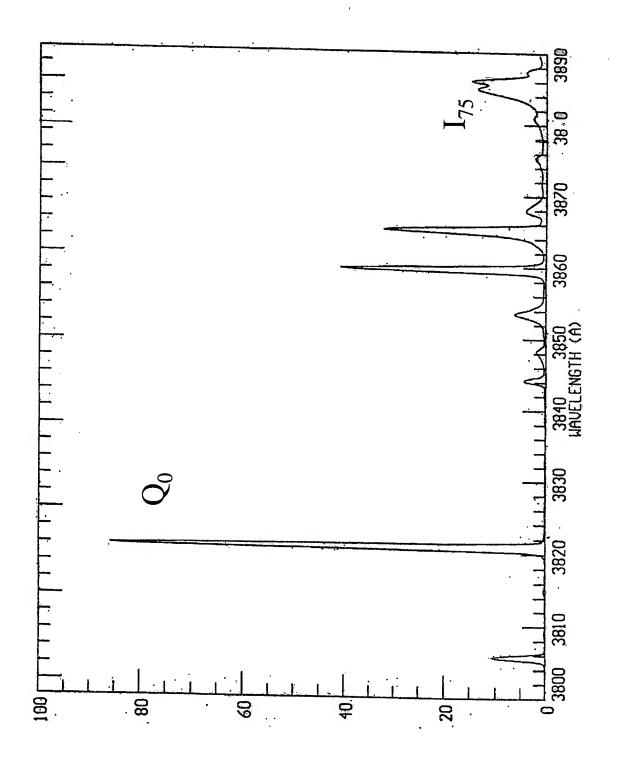


Figure 1

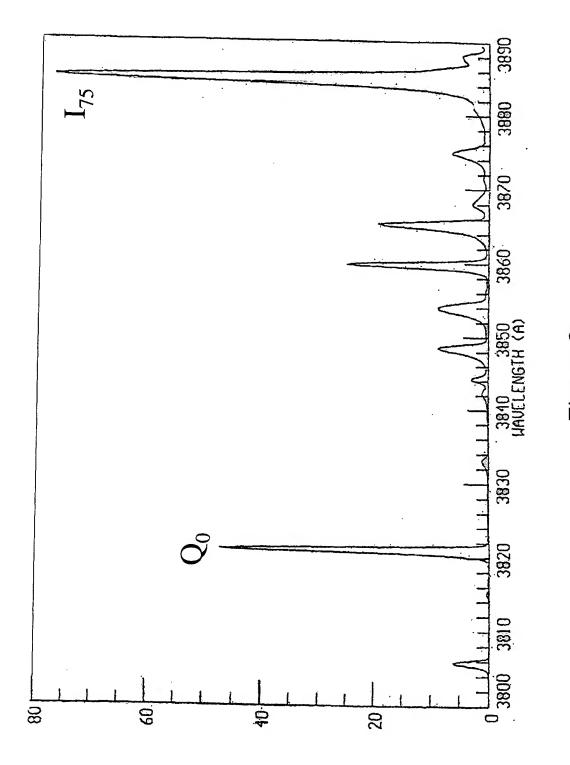


Figure 2